

Electronic Patent Application Fee Transmittal

Application Number:	10772740
Filing Date:	05-Feb-2004
Title of Invention:	Method of plasma enhanced chemical vapor deposition of diamond using methanol-based solutions
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Filer:	Jonathan O Owens
Attorney Docket Number:	220101-1011

Filed as Small Entity

Utility under 35 USC 111(a) Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	2801	1	405	405
Total in USD (\$)				405